



00862.022170

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: D. Vanore
Haruhiro ONO et al.)	
	:	Group Art Unit: 2881
Application No.: 09/819,907)	
	:	
Filed: March 29, 2001)	
	:	
For: ELECTRON OPTICAL SYSTEM,)	July 25, 2003
CHARGED-PARTICLE BEAM EXPOSURE	:	
APPARATUS USING THE SAME, AND)	
DEVICE MANUFACTURING METHOD	:	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statements filed on October 23, 2001, and January 29, 2003, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

Where possible, Applicants have provided copies of corresponding patents or published applications corresponding to those applications cited in the above-referenced October 23, 2001, Information Disclosure Statement.

To clarify the record, Applicants have corrected the citation to U.S. Patent No. 6,381,072.

The Examiner's attention is also directed to the following copending U.S. patent application. A copy of this application is also enclosed.

RECEIVED
JUL 28 2003
TECHNOLOGY CENTER 2800

Application Number

09/819,737

Filing Date

March 29, 2001

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee under is believed to be due with the filing of this paper. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should it be deemed that a fee is due for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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SEW/eab

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) July 25, 2003				ATTY DOCKET NO. 00862.022170		APPLICATION NO. 09/819,907	
				APPLICANT Haruhiro ONO et al.			
				FILING DATE March 29, 2001		GROUP 2881	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	4,200,794	04/29/1980	Newberry et al.	250	396		
	5,215,623	06/01/1993	Takahashi et al.	156	644		
	6,274,877	08/14/2001	Muraki	250	492.23		
	6,323,499	11/27/2001	Muraki et al.	250	492.22		
	6,337,485	01/08/2002	Muraki et al.	250	492.2		
	6,381,072	04/30/2002	Burger	359	622		
	6,469,799	10/22/2002	Kajita	358	1.16		
	6,472,672	10/29/2002	Muraki	250	492.2		
	6,483,120	11/19/2002	Yui et al.	250	491.1		
	6,515,409	02/04/2003	Muraki et al.	313	359.1		
	2002/0054690 A1	12/27/2001	Shimada et al.	250	306		
	2001/0052576 A1	12/20/2001	Shimada et al.	250	492.1		
	2002/0008207 A1	01/24/2002	Muraki et al.	250	398		
	2002/0051111 A1	05/02/2002	Greene et al.	349	149		
	2002/0005491 A1	01/17/2002	Yagi et al.	250	396		
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.